

LIST OF PUBLICATIONS/MATERIALS CITED BY APPLICANT		Attorney Docket No. SEL 137 DIV		09/821,473
		Applicant Yamazaki et al.		
		Filing Date March 29, 2001		
U.S. PATENT DOCUMENTS				
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	FILING DATE
Lee	6,143,661	11/1/00	Kousai et al.	8/13/98
	6,348,369	2/19/02	Kusumoto et al.	9/3/99
	6,482,752	11/19/02	Yamazaki et al.	7/24/96
FOREIGN PATENT DOCUMENTS				
	DOCUMENT NUMBER	DATE	COUNTRY	FILING DATE

OTHER PUBLICATIONS/MATERIALS (Including Author, Title, Date, Pertinent Pages)	
Lee	Hayashi et al.; "Fabrication Of low-Temperature Bottom-Gate Poly-Si TFTs on Large-Area Substrate by Linear-Beam Excimer Laser Crystallization and Ion Doping Method", IEDM 95, p. 33.3.1 - 33.3.4 (1995)

EXAMINER:  Kueh Minj Lee	DATE CONSIDERED:  2/21/03
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPHP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.	